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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Fang-Cheng Chen, et al.

Serial No.: 10/731,346

Filed: December 9, 2003

For: METHOD OF FORMING A
SEMICONDUCTOR DEVICE
WITH A HIGH DIELECTRIC
CONSTANT MATERIAL AND AN
OFFSET SPACER

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Attorney Docket No.
2002-1367 / 24061.504

Customer No. 42717

Group Art Unit: 2813

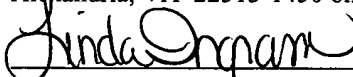
Examiner: Thanh T. Nguyen

Confirmation No.: 3543

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

I hereby certify that this correspondence is being
deposited with the United States Postal Service as
first class mail in an envelope addressed to the
Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450 on June 22, 2006.


Linda Ingram

AMENDMENT UNDER 37 CFR §1.111

This Amendment is submitted in reply to the Office Action mailed on February 21, 2006.
Applicants are enclosing a Petition for a two-month time extension, and check in the amount of
the required extension fee.